

PATENT ABSTRACTS OF JAPAN

(11)Publication number : 11-245376

(43)Date of publication of application : 14.09.1999

(51)Int.Cl.

B41F 15/44

B05D 1/40

B41M 1/12

(21)Application number : 10-066173

(71)Applicant : RICOH CO LTD

(22)Date of filing : 02.03.1998

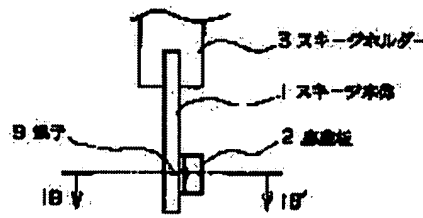
(72)Inventor : SHIMIZU TOMOHITO
YAMAMOTO KAZUTADA
ISHIURA SUKEAKI
ONODA SHIGEO
ITO YOSHIHIKO

(54) METHOD AND APPARATUS FOR COATING SQUEEGEE, SCREEN

(57)Abstract:

PROBLEM TO BE SOLVED: To reduce an unevenness of a film thickness after coating with an ink by mounting a plurality of baffle plates perpendicularly at a squeegee surface in a widthwise direction of a squeegee body, thereby making an ink liquid amount held in the width direction of the squeegee uniform.

SOLUTION: A plurality of baffle plates 2 are installed perpendicularly at a squeegee surface at a certain interval in a width direction of a squeegee body 1 by a screw 9 or the other fastening means. The plates 2 are preferably aligned at an installing interval of 10 to 50 mm in the width direction of the body 1. And, a thickness of each of the plates 2 is preferably 0.3 to 2 mm. And, a length of the plate 2 of the squeegee in a perpendicular direction to the body 1 is 10 to 50 mm, and a length of the plate 2 in a parallel direction with the body 1 is 10 to 50 mm. And, a position of a lower end side of the plate 2 is raised 1 to 5 mm from an end of the body 1.



LEGAL STATUS

[Date of request for examination]

[Date of sending the examiner's decision of rejection]

[Kind of final disposal of application other than the examiner's decision of rejection or application converted registration]

[Date of final disposal for application]

[Patent number]

[Date of registration]

[Number of appeal against examiner's decision of rejection]

[Date of requesting appeal against examiner's decision of rejection]

[Date of extinction of right]

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